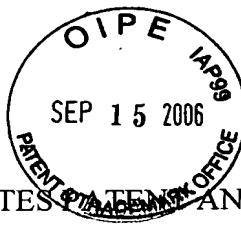


DOCKET NO.: 285995US26PCT



11W

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF:

GROUP: 2812

Kohei KAWAMURA, et al.

SERIAL NO: 10/567,733

ATTENTION:

FILING RECEIPT CORRECTIONS

FILED: February 10, 2006

FOR: METHOD FOR FORMING FILM, METHOD FOR MANUFACTURING
SEMICONDUCTOR DEVICE, SEMICONDUCTOR DEVICE AND
SUBSTRATE TREATMENT SYSTEM

REQUEST FOR CORRECTED OFFICIAL FILING RECEIPT

Office of Initial Patent Examination
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The Patent Office is requested to provide a corrected Official Filing Receipt for the following.

PLEASE NOTE THAT THE NUMBER OF DRAWINGS IS INCORRECT. IT SHOULD READ AS FOLLOWS:

DRAWINGS: 9

PLEASE NOTE THAT THE APPLICANT'S CITY IS INCORRECT. IT SHOULD READ AS FOLLOWS:

KOHEI KAWAMURA, NIRASAKI-SHI, JAPAN

YASUO KOBAYASHI, NIRASAKI-SHI, JAPAN

KENICHI NISHIZAWA, NIRASAKI-SHI, JAPAN

YASUHIRO TERAJ, NIRASAKI-SHI, JAPAN

AKIRA ASANO, NIRASAKI-SHI, JAPAN

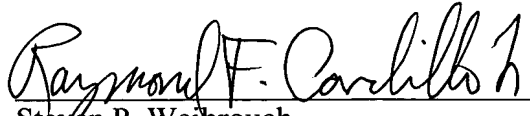
PLEASE NOTE THAT THE ASSIGNMENT FOR PUBLISHED PATENT APPLICATION DATA IS MISSING. IT SHOULD READ AS FOLLOWS:

TOKYO ELECTRON LIMITED, MINATO-KU, JAPAN

No fees are required. If you have any questions, please do not hesitate to contact us.

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.

A handwritten signature in cursive script, reading "Raymond F. Cardillo, Jr.", written over a horizontal line.

Steven P. Wehrouch

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(OSMMN 03/06)

285995US-2459-2312-26-PCT

10/567,733

DOCKET NO.: 285995US26PCT

SERIAL NO: 10/567,733

UNITED STATES DEPARTMENT OF COMMERCE
United States Patent and Trademark Office
Address: COMMISSIONER FOR PATENTS
 P.O. Box 1450
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www.uspto.gov

CONFIRMATION NO. 7700

OC000000019442715

Early Publication Request: No

Title

Method for forming film, method for manufacturing semiconductor device, semiconductor device and substrate treatment system

Preliminary Class

438

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